

FOR IMMEDIATE RELEASE
August 2005

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Lambda Technologies, Inc. Initiates Development Collaboration with Fraunhofer USA and Michigan State University for Microwave CVD Diamond Applications

As part of Lambda's strategy for supporting its new microwave CVD diamond product line, the company has entered into a consulting and development relationship with the Fraunhofer Center for Coating and Laser Applications, located at Michigan State University. In 2004, Lambda Technologies obtained the exclusive license rights to MSU's tunable microwave technology for materials processing, which included numerous patents for diamond CVD reactor geometry and process techniques. Recently, Lambda announced their initial product line for diamond applications into that market.

Joe Wander, Director of New Product Development at Lambda Technologies, said "the relationship with Fraunhofer and MSU allows Lambda to focus on the company's core competency of the equipment design and features, while utilizing the development resources and extensive experience at the MSU facility to provide diamond film process and applications support to us and our customers.

Lambda Technologies, Inc. is a capital equipment and process development company specializing in applying proprietary microwave technologies for the processing of advanced materials and other high value added heating applications.